

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: KAJI, et al.

Filed: March 6, 2002

For: EMISSION SPECTROSCOPIC PROCESSING APPARATUS AND
PLASMA PROCESSING METHOD USING IT



CLAIM FOR PRIORITY

Assistant Commissioner for Patents
Washington, D.C. 20231

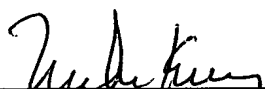
March 6, 2002

Sir:

Under the provisions of 35 USC §119 AND 37 CFR § 1.55,
Applicants hereby claim the right of priority based on Patent
Application No. 2001-364626 filed in Japan on November 29,
2001.

Respectfully submitted,

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